


Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1531		SERIAL NO. 09/755,673	
 <p>LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)</p>				APPLICANT Leonard Forbes, et al.			
FILING DATE January 5, 2001				GROUP 2823			
U.S. PATENT DOCUMENTS							
*Examiner Initial	AA	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
K.N.	AA	6,246,076	06/01	Lipkin, et al.			
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
	AB						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
K.N.	AC	S. Ogawa, et al., Silicon-Aluminum Oxynitride Composite Films Deposited by Reactive Ion Beam Sputtering.				IEEE 1999, pp. 775-778.	
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
EXAMINER <i>K. Bremminger</i>				DATE CONSIDERED <i>12/24/03</i>			
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>							

EV085429671